



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q88662

Takenori OSADA, et al.

Appln. No.: 10/540,513

Group Art Unit: 2826

Confirmation No.: 6641

Examiner: Eduardo A. RODELA

Filed: June 23, 2005

For: COMPO

COMPOUND SEMICONDUTOR EPITAXIAL SUBSTRATE AND METHOD FOR

MANUFACTURING THE SAME

NOTICE OF APPEAL

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Applicant hereby appeals to the Board of Patent Appeals and Interferences from the final Office Action dated March 19, 2007.

The statutory fee of \$500.00 is being charged to Deposit Account No. 19-4880. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this Notice is attached.

Respectfully submitted,

SUGHRUE MION, PLLC

Telephone: (202) 293-7060

Facsimile: (202) 293-7860

washington office 23373

CUSTOMER NUMBER

ohn T. Callahan

Registration No. 32,607

09/14/2007 SZEWDIE1 00000008 194880 10548513

02 FC:1401

509.09 DA

Date: September 13, 2007